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TECHNOLOGY CENTER R3700

PATENT APPLICATION 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: HIROSHI IZAWA ET AL.

03500.015313.

Application No.: 09/837,459

Filed: April 19, 2001

For: DEPOSITED-FILM FORMATION APPARATUS, DEPOSITED-FILM FORMATION PROCESS, VACUUM

SYSTEM, LEAK JUDGMENT METHOD, AND COMPUTER-READABLE RECORDING MEDIUM

WITH RECORDED LEAK-JUDGMENT-EXECUTABLE

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DET 28 2003

Commissioner for Patents TC 1700 Washington, D.C. 20231

Examiner: Not Yet Assigned

Group Art Unit: 2857

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The Examiner's attention is also directed to the following U.S. applications:

APPLICATION NO.
08/704,138
09/469,797
09/478,885
09/867,493

FILING DATE
08/28/96
12/22/99
01/07/00
05/31/01

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A copy of each cited application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No.

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3801 Facsimile: (212) 218-2200

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